



TRANSMITTAL LETTER
(General - Patent Pending)

Docket No.
Beaumont-27

In Re: Application of: Alain Straboni

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit	Confirmation No.
10/552,548	October 12, 2005	Not Yet Assigned	45722	Not assigned	Not assigned

Title: **SINTERED SEMICONDUCTOR MATERIAL**

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Information Disclosure Statement (2 pgs.), Information Disclosure Citation (2 pgs.), International Search Report (4 pgs.), Cited References (10), Return Postcard

in the above identified application.

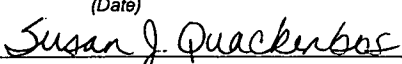
- ☒ No additional fee is required.
- ☐ A check in the amount of _____ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **50-3208** as described below.
 - ☐ Charge the amount of _____
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- ☐ Payment by credit card. Form PTO-2038 is attached.

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Signature

Dated: April 7, 2006

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on April 7, 2006 (Date)	
	
Signature of Person Mailing Correspondence	
Susan J. Quackenbos	
Typed or Printed Name of Person Mailing Correspondence	

cc:



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Alain Straboni : Art Unit: Not Yet Assigned
Serial No.: 10/552,548 : Docket No.: Beaumont-27
Filed: 10/12/2005 : Examiner: Not Yet Assigned
For: SINTERED SEMICONDUCTOR :
MATERIAL :

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant submits herewith copies of references or other information of which it is aware that it believes may be material to the examination of this application, and in respect to which, there may be a duty to disclose under 37 C.F.R. § 1.56 and in accordance with 37 C.F.R. §§ 1.97-1.98.

The filing of this information disclosure statement shall not be construed as a representation that a search has been made (37 C.F.R. 1.97(g)), or an admission that the information is material to patentability (37 C.F.R. 1.97(h)), or an admission that the information constitutes prior art.

The filing of this information disclosure statement shall not be construed as an admission against interest in any manner. Should there be any fees due and owing with

CERTIFICATE OF MAILING

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By: Susan J. Quackenbos

Typed or Printed Name: Susan J. Quackenbos

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /BS/

respect to this application, the Examiner is authorized to charge such fees to Deposit Account No. 50-3208.

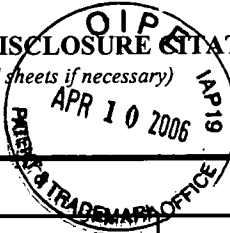
The Examiner is respectfully requested to review the references identified herewith and make them of record in the instant application as required by M.P.E.P. § 609. The Examiner is also requested to initial one copy of Form PTO-1449 and return same to the undersigned.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'Edward J. Howard', is written over a horizontal line.

Edward J. Howard
Registration No. 42,670
Plevy, Howard & Darcy, PC
P.O. Box 226
Fort Washington, PA 19034
Telephone: (215) 542-5824
Facsimile: (215) 542-5825
Attorneys for Applicant

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number (Optional) Beaumont-27		Application Number 10/552,548	
				Applicant(s) Alain Straboni			
				Filing Date October 12, 2005		Group Art Unit Not Yet Assigned	



U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		5,378,289	01/03/95	Noguchi et al.			

U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS								
	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		GB 1065773 /	04/19/67	Great Britain				
		DE 2258305	05/30/74	Germany			✓	
		JP 11323538 /	11/26/99	Japan			✓	
		EP 0977274 /	02/02/00	Europe				
		DE 19859288 /	06/29/00	Germany			✓	

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
1		Santana C. J. et al., "The Effects of Processing Conditions on the Density and Microstructure of Hot-Pressed Silicon Powder", JOURNAL OF MATERIALS SCIENCE, vol. 31, 1996, pgs. 4985-4990
6		Bere E. et al., "A New Technology for the Production of Silicon Sheets by Sintering of Silicon Powder Beds" 17th E.C. Photovoltaic Solar Energy Conference, Munich Germany Oct. 22-26, 2001, Proceedings of the International Photovoltaic Solar Energy Conference, Munich: WIP-RENEWABLE ENERGIES, DE, vol. 2 of 3 Conf. 17, Oct. 22, 2001, pgs. 1799-1801.

EXAMINER <div style="text-align: center;">/Bradley Smith/</div>	DATE CONSIDERED <div style="text-align: center;">01/03/2010</div>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)				ATTY DOCKET NO. Beaumont-27		APPLICATION NO. 10/552,548	
				APPLICANT(S) Alain Straboni			
				FILING DATE October 12, 2005		GROUP ART UNIT Not Yet Assigned	
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U.S. PATENT APPLICATION PUBLICATIONS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
		JP 2002151713 /	05/24/02	Japan			✓
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
		/ Belogorokhov A. I. et al, "Optical characterization of porous silicon embedded with CdSe nanoparticles", APPLIED PHYSICS LETTERS, AMERICAN INSTITUTE OF PHYSICS. NEW YORK, US, vol. 73, no. 19, November 19, 1998, pgs. 2766-2768					
		/ International Search Report dated September 27, 2004 for related PCT Application No. PCT/FR2004/050151.					
EXAMINER /Bradley Smith/				DATE CONSIDERED 01/03/2010			

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